Docket No.: 50006-135

## **PATENT**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of

Customer Number: 20277

Tomohiro HOSOKAWA, et al.

Confirmation Number: 9571

Serial No.: 10/026,551

Group Art Unit: 2812

Filed: December 27, 2001

Examiner: Andre C. Stevenson

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SYSTEM FOR

MANUFACTURING THE SAME

## INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

10/026,551

CERTIFICATION PARAGRAPH

The undersigned certifies that, to the best of his knowledge, each item of information

contained in this Information Disclosure Statement was first cited in a communication from a

foreign patent office in a counterpart foreign application not more than three months prior to the

filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application

search report or office action and its relevance discussed therein. A copy of the foreign search

report or office action, together with an English language version thereof, is attached for the

Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including

extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit

account.

Respectfully submitted,

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Date: October 22, 2003

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION						ATTY. DOCKET NO. <b>50006-135</b>		SERIAL NO. 10/026,551				
OCT 2 2 2003						APPLICANT Tomohiro HOSOKAWA, et al.						
(PTO-1449)						FILING DATE GRO December 27, 2001 281						
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EXAMINER DATE CONSIDERED												

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.